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1. 30. (New) An illumination system for light having wavelengths ≤ 193 nm, comprising:
a first field raster element for receiving a first diverging portion of said light and directing a first bundle of said light;
a second field raster element for receiving a second diverging portion of said light and directing a second bundle of said light, wherein said first field raster element is oriented at an angle with respect to said second field raster element to cause a center ray of said first bundle to intersect with a center ray of said second bundle at an image plane; and
an optical element for imaging secondary sources of said light in an exit pupil, wherein said optical element is situated in a path of said light after said first and second field raster elements and before said image plane.

2. 31. (New) The illumination system of claim 30, wherein said first field raster element is movable so that said angle can be altered.

3. 32. (New) The illumination system of claim 30, wherein said first and second field raster elements produce said secondary sources of said light.

4. 33. (New) The illumination system of claim 30, wherein said first and second field raster elements have positive optical power.

5. 34. (New) The illumination system of claim 30, wherein said illumination system produces images of said first and second field raster elements that are superimposed, at least partially, in said image plane.

6. 35. (New) The illumination system of claim 30, wherein said first and second field raster elements are rectangular in shape.

1. ~~36~~¹. (New) The illumination system of claim ~~30~~¹, wherein said optical element forms a ring field of said light in said image plane.

8. ~~37~~¹. (New) The illumination system of claim ~~30~~¹, wherein said illumination system further comprises:

a first pupil raster element for receiving and directing said first bundle from said first field raster element; and

a second pupil raster element for receiving and directing said second bundle from said second field raster element.

9. ~~38~~⁸. (New) The illumination system of claim ~~37~~⁸, wherein said first and second pupil raster elements are located at or nearby a site of said secondary sources of said light.

10. ~~39~~⁸. (New) The illumination system of claim ~~37~~⁸,

wherein said first pupil raster element images said first field raster element in said image plane, and

wherein said second pupil raster element images said second field raster element in said image plane.

11. ~~40~~¹⁰. (New) The illumination system of claim ~~39~~¹⁰, wherein said illumination system provides a one-to-one correlation between said first and second field raster elements and said first and second pupil raster elements.

12. ~~41~~¹. (New) The illumination system of claim ~~40~~¹, further comprising a second optical element for providing said first and second diverging portions of said light to said first and second field raster elements.

13. ~~42~~¹. (New) The illumination system of claim ~~40~~¹, wherein said wavelengths are in a range of about 10 nm to 15 nm.

14. 43. (New) A projection exposure apparatus for microlithography, comprising:
the illumination system of claim 30;
a first carrier for positioning a mask in said image plane of the illumination system;
a second carrier for a light sensitive object; and
a projection objective having an entrance pupil in a same plane as said exit pupil of the
illumination system, for imaging said mask onto said light sensitive object.

15. 44. (New) A process for producing a microelectronic component, comprising utilizing the
projection exposure apparatus of claim 43.

16. 45. (New) An illumination system for light having wavelengths ≤ 193 nm, comprising:
a first field raster element for receiving a first diverging portion of said light and directing a
first bundle of said light;
a second field raster element for receiving a second diverging portion of said light and
directing a second bundle of said light, wherein said first field raster element is
oriented at an angle with respect to said second field raster element to cause a center
ray of said first bundle to intersect with a center ray of said second bundle at an
image plane; and
an optical element for imaging secondary sources of said light in an exit pupil, wherein said
optical element is situated in a path of said light after said first and second field raster
elements and before said image plane,
wherein said first and second field raster elements are of a rectangular shape, produce said
secondary sources of said light, and have positive optical power,
wherein said illumination system produces images of said first and second field raster
elements that are superimposed, at least partially, in said image plane, and
wherein said optical element forms a ring field of said light in said image plane.

17. 46. (New) The illumination system of claim 45, wherein said illumination system further
comprises:

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a first pupil raster element for receiving and directing said first bundle from said first field raster element; and
a second pupil raster element for receiving and directing said second bundle from said second field raster element.

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18. ~~47~~. (New) The illumination system of claim ~~46~~, wherein said first and second pupil raster elements are located at or nearby a site of said secondary sources of said light.

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19. ~~48~~. (New) The illumination system of claim ~~46~~,
wherein said first pupil raster element images said first field raster element in said image plane, and
wherein said second pupil raster element images said second field raster element in said image plane.

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20. ~~49~~. (New) The illumination system of claim ~~48~~, wherein said illumination system provides a one-to-one correlation between said field raster elements and said pupil raster elements.

21. ~~50~~. (New) An illumination system for wavelengths ≤ 193 nm, particularly for EUV lithography with
a primary light source;
a device for producing secondary light sources comprising at least a first mirror and one or more first optical elements, which are arranged between the device and an image plane of the illumination system,
wherein the first optical elements image the secondary light sources in an exit pupil of the illumination system;
wherein the device for producing secondary light sources comprises a collector unit, wherein a diverging beam is impinging on the collector unit,
wherein the collector unit comprises one or more second optical elements for collecting the diverging beam,

wherein the second optical element comprises a first mirror or lens which is divided into raster elements

wherein the raster elements are arranged to collect the diverging beam.

22. ²¹51. (New) The illumination system of claim ²¹50, wherein said raster elements are rectangular in shape.

23. ²¹52. (New) The illumination system of claim ²¹50, wherein said first optical elements form a ring field of said light in said image plane.

24. ²¹53. (New) An illumination system for light having wavelengths ≤ 193 nm, comprising:
a first field raster element for receiving a first diverging portion of said light and directing a first bundle of said light;
a second field raster element for receiving a second diverging portion of said light and directing a second bundle of said light, wherein said first field raster element is oriented at an angle with respect to said second field raster element to cause a center ray of said first bundle to intersect with a center ray of said second bundle at an image plane of said illumination system, and wherein said first and second field raster elements produce secondary sources of said light; and
an optical element for imaging said secondary sources of said light in an exit pupil of said illumination system, wherein said optical element is situated in a path of said light after said first and second field raster elements and before said image plane, wherein said illumination system produces images of said first and second field raster elements that are superimposed, at least partially, in said image plane.

25. ²⁴54. (New) The illumination system of claim ²⁴53, wherein said first and second field raster elements are rectangular in shape.

26. ²⁴55. (New) The illumination system of claim ²⁴53, wherein said optical element forms a ring field of said light in said image plane.

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27. ²⁴56. (New) The illumination system of claim ²⁴53, wherein said optical element comprises a wobbling mirror.

28. ²⁷57. (New) The illumination system of claim ²⁷56, wherein said wobbling mirror is situated close to said image plane.

29. ²⁴58. (New) The illumination system of claim ²⁴53, wherein said optical element comprises a mirror with a dynamically deformable mirror surface.

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